



3743

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*Auth. [Signature]*

9/8/01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Shih, et al

Group Art Unit: 3743

Serial No.: 09/410,896

Examiner: L. Ciric

Filed: October 2, 1999

In Response to Office Action

Dated: May 23, 2001

For:

Apparatus And Method For Cooling A  
Semiconductor Substrate

RECEIVED

SEP - 5 2001

Attorney Docket No.: 67,200-207

TECHNOLOGY CENTER R3700

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I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231.

*[Signature]*  
Kathy Dixon

Date: August 22, 2001

RESPONSE TO OFFICE ACTION

Assistant Commissioner  
for Patents  
Washington, D.C. 20231

Dear Sir:

In response to an Office Action mailed May 23, 2001,  
please enter the following amendments and consider the following  
remarks.